

INFORMATION DISCLOSURE CITATION	Attorney Docket No.: 47233-0044-00-US	Serial No.: 10/507,127
(Use several sheets if necessary)	Applicants Keiichi ABE et al.	Page 1 of 1
PTO Form 1449	Filing Date: September 10, 2004	Group Art Unit: 1794

U.S. PATENT DOCUMENTS

*Examiner Initial	Document Number	Date	Name	Class	Sub Class	Filing Date

FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Sub Class	Translation	
						YES	NO

OTHER DOCUMENTS

(Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.)

/LT/	ISHIKAWA et al., "Thin-Layer Chromatography – Basis and Applications," December 10, 1963, pp 9-11, Nanzando Co., Ltd., Japan (partial translation)

Examiner /Lien Tran / (10/14/2008)	Date Considered 10/14/2008
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Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.